

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENCE
CONVEYING PARTY DATA	
Name	Execution Date
Rensselaer Polytechnic Institute	11/03/2006
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd.
Internal Address:	rm 1265
City:	Arlington
State/Country:	VIRGINIA
Postal Code:	22230
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	11509810
CORRESPONDENCE DATA	
Fax Number:	(703)292-9041
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	703-292-8060
Email:	sbattle@nsf.gov
Correspondent Name:	Robin C. Fritsch
Address Line 1:	4201 Wilson Blvd.
Address Line 2:	rm 1265
Address Line 4:	Arlington, VIRGINIA 22230
NAME OF SUBMITTER:	R. Fritsch
Total Attachments: 1 source=Conf_lic64524#page1.tif	



Rensselaer

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Invention Title: Carbon nanotube growth on bulk metallic substrate using vapor phase catalyst delivery: Nanotube on (INCONEL 600)

Inventors: Saikat Talapatra, Swastik Kar, Sunil Pal, Robert Vajtai, Pulickel M. Ajayan

U.S. Filing Date: 08/25/2006

Application Serial No.: 11/509,810

Grant/Contract Number(s): NSF - 0117792

RPI Institution No.: 1041

The invention identified above is Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above identified grant or contract award from the United States Government. This document is confirmatory of:

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The government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 3 day of November , 2006.

By: Charles F. Rancourt

Director, Office of Technology Commercialization

For: Rensselaer Polytechnic Institute

At: Rensselaer Polytechnic Institute - 110 8th Street - Office of Technology Commercialization
J Bldg - Troy, NY 12180

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